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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Latchford, et al.

Serial No.: 09/921,938

Confirmation No.: 8367

Filed: August 2, 2001

For: Photolithography Scheme
Using a Silicon Containing
Resist§
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Group Art Unit: 1752

Examiner: Amanda Walke

Mail Stop AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

CERTIFICATE OF MAILING	
37 CFR 1.8	
I hereby certify that this correspondence is being deposited on September 7, 2004, with the United States Postal Service as First Class Mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.	
September 7, 2004	<i>Kris Z. Zuhra</i>
Date	Signature

RESPONSE TO OFFICE ACTION DATED JUNE 4, 2004

In response to the Office Action dated June 4, 2004, having a shortened statutory period for response set to expire on September 7, 2004, please enter this response and reconsider the claims pending in the application for reasons discussed below. The Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/4227.P1/KMT, the fee of \$90.00 for 5 additional claims and for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper. **Remarks** begin on page 9 of this paper

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